



**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.:

10/706,862

Confirmation No.: 6724

Applicant(s):

Ogihara, et al.

Filed:

November 12, 2003

Art Unit:

1711

Examiner:

Irina S. Zemel

Title:

COMPOSITION FOR FORMING POROUS FILM, POROUS FILM AND

METHOD FOR FORMING THE SAME, INTERLEVEL INSULATOR FILM,

AND SEMICONDUCTOR DEVICE

Docket No.:

035576/271443

Customer No.: 00826

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT UNDER 37 C.F.R. § 1.121

Sir:

In response to the Office Action dated December 1, 2005, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.